

NOV 03 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Turner, et al.

Attorney Docket No.: NOVLP074/NVLS-000414

Application No.: 09/998,993

Examiner: Maldonado, Julio J.

Filed: November 15, 2001

Group: 2823

Title: PHOSPHOROUS-DOPED SILICON
DIOXIDE PROCESS TO CUSTOMIZE
CONTACT ETCH PROFILES**CERTIFICATE OF FACSIMILE TRANSMISSION**

I hereby certify that this correspondence is being transmitted by facsimile to fax number 571-273-8300 to the U.S. Patent and Trademark Office on November 3, 2005.

Signed: 

Tara Hayden

AMENDMENT TRANSMITTALCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

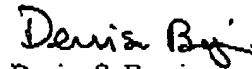
The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	23	MINUS	25	00	x 25 =	x 50 =
Independent Claims	05	MINUS	05	00	x 100 =	x 200 =
Multiple Dependent Claim Present and Fee Not Previously Paid						
Total					\$	\$

- ☒ Applicant(s) hereby petition for a three month extension(s) of time to respond to the aforementioned Office Action.
- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.
- ☐ Enclosed is our Check No. _____ in the amount of \$ _____ to cover the additional claim fee and/or extension of time fees.
- ☒ Please charge \$1,020.00 or any additional fees required to facilitate filing the attached response, to Deposit Account No. 500388 (Order No. NOVLP074).

11/04/2005 HDESS1 00000068 500388 09998993

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Respectfully submitted,
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